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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Group Art Unit: 2824

Application No.: 10/805,238

Examiner:

Filed: March 22, 2004

Docket No.: 119169

For: ELECTRODE, METHOD OF MANUFACTURING THE SAME, FERROELECTRIC
MEMORY, AND SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited in the European Search Report. An English language version of the International Search Report is attached for the Examiner's information.
- ☒ 3. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.

Respectfully submitted,

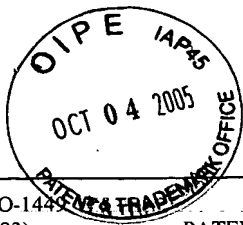
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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>

Sheet 1 of 1Form PTO-1449 US Dept. of Commerce
(REV. 8-83) PATENT & TRADEMARK OFFICEATTY DOCKET NO.
119169APPLICATION NO.
10/805,238

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANTS
Takeshi KIJIMA et al.FILING DATE
March 22, 2004GROUP
2824

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	1	US 2002/030210 A1	03-14-2002	Matsui et al.		
	2	US 6,117,689 A	09-12-2000	Summerfelt et al.		
	3	US 2002/102826 A1	08-01-2002	Shimamoto et al.		

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER

DATE CONSIDERED

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: October 4, 2005